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APPLICANTS

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** CONTINUING DATA *****

NONE

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** FOREIGN APPLICATIONS *****

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S.B.G.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed: 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY NETHERLANDS	SHEETS DRAWING 2	TOTAL CLAIMS 109	INDEPENDENT CLAIMS 1
Verified and Acknowledged	Examiner's Signature M.D. 6/ S.B.G.	Initials			

ADDRESS

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6/1/04
 Method of making a surface mountable semiconductor device
 TITLE USING A FLEXIBLE FILM AND A SEMICONDUCTOR DEVICE
~~Method of manufacturing a semiconductor device and a semiconductor device obtained by means of said method~~
 OBTAINED BY MEANS OF SAID METHOD

FILING FEE	RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)